

In re Application of:

HITOSHI NAKANO

Application No.: 09/536,637

Filed: March 28, 2000

For: APPARATUS WITH AIR-CONDITIONING  
SYSTEM, AND DEVICE MANUFACTURING  
METHOD USING THE SAME

COMMISSIONER FOR PATENTS

BOX AF

Washington, D.C. 20231

Docket No.: 00684.002985

Examiner: L. Ciric

Group Art Unit: 3743

Date: April 26, 2002



AFY/3743

RECEIVED  
APR 30 2002  
TECHNOLOGY CENTER 3100

Sir:

Transmitted herewith is an Amendment After Final Rejection in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	18	MINUS	20	= 0	x \$9 \$18	\$ -0-
INDEP. CLAIMS	2	MINUS	3	= 0	x \$42 \$84	\$ -0-
Fee for Multiple Dependent claims \$140°/\$280						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$ -0-

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

☐ A check in the amount of \$\_\_\_\_ is enclosed.

☐ Charge \$\_\_\_\_ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.


☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

☒ A check in the amount of \$ 110.00 to cover the fee for a ONE month extension is enclosed.

☐ A check in the amount of \$        to cover the Information Disclosure Statement fee is enclosed.

☒ Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicant

Registration No. 32,533

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

SDM/vmm

DC\_MAIN 95140 v 1

684.2985



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

LD  
5-2-02  
#13

In re Application of: )  
: Examiner: L. Ciric  
HITOSHI NAKANO )  
: Group Art Unit: 3743  
Application No.: 09/536,637 )  
:   
Filed: March 28, 2000 )  
:   
For: APPARATUS WITH AIR- ) April 26, 2002  
: CONDITIONING SYSTEM, AND  
: DEVICE MANUFACTURING  
: METHOD USING THE SAME )

Commissioner for Patents  
Washington, D.C. 20231

REQUEST TO MAKE DRAWING CHANGES

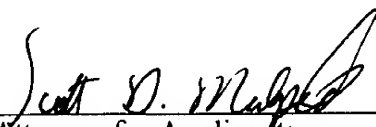
Sir:

Enclosed, in accordance with U.S. Patent and Trademark Office Practice, are copies of proposed drawing changes shown in red ink, wherein Figure 1 is amended to locate the semiconductor manufacturing equipment, the inspection equipment and measuring equipment within chamber 1.

Approval of the drawing corrections by the Examiner is respectfully requested.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

  
Attorney for Applicants

Registration No. 32,533

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

SDM/vmm  
DC\_MAIN 95140 v 1